

EAST Search History**EAST Search History (Prior Art)**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	491	156/345.31,32.ccls.	US-PGPUB; USPAT	OR	ON	2010/11/18 21:00
L2	25875	118/7\$.ccls. 156/345. \$.ccls.	US-PGPUB; USPAT	OR	ON	2010/11/18 21:04
L3	4933	(substrate wafer work \$1piece semi \$1conductor) near10 (float\$3 slid\$3 elevat \$3 glid\$3 hover\$3) near10 (air gas)	US-PGPUB; USPAT	OR	ON	2010/11/18 21:04
L6	6652	(slide sliding push\$3 pull\$3) near9 (wafer substrate semi \$1conductor tray platform table) with arm	US-PGPUB; USPAT	OR	ON	2010/11/18 21:06
L7	218	2 and 6	US-PGPUB; USPAT	OR	ON	2010/11/18 21:06
L8	637	2 and 3	US-PGPUB; USPAT	OR	ON	2010/11/18 21:06
L11	1440	(substrate wafer semi \$1conductor) near10 (float\$3) near10 (air gas)	US-PGPUB; USPAT	OR	ON	2010/11/18 21:17
L12	1233	11 not 8	US-PGPUB; USPAT	OR	ON	2010/11/18 21:18
L13	673	(slide sliding push\$3 pull\$3) near9 (wafer substrate semi \$1conductor tray platform table) with arm	JPO	OR	ON	2010/11/18 21:20

L15	668	(substrate wafer work \$1piece semi \$1conductor) near10 (float\$3 slid\$3 elevat \$3 glid\$3 hover\$3) near10 (air gas)	JPO	OR	ON	2010/11/18 21:20
-----	-----	---	-----	----	----	---------------------

EAST Search History (Interference)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L17	599	(arm near8 (slid\$3 push\$ pull\$3 moving move) with (semi\$1conductor substrate wafer)). clm.	USPAT; UPAD	OR	ON	2010/11/18 21:37
L23	160	((semi\$1conductor substrate wafer) near9 (glid\$3 slid\$3 float\$3) near9 (air gas)).clm.	USPAT; UPAD	OR	ON	2010/11/18 21:40
L25	31	(arm near15 (contact \$3 engag\$3) near15 (tray) near15 (releas \$3)).clm.	USPAT; UPAD	OR	ON	2010/11/18 21:42

11/18/2010 9:43:06 PM**C:\Documents and Settings\nford\My Documents\EAST\Workspaces\10.585858 - Floating
substrate.wsp**